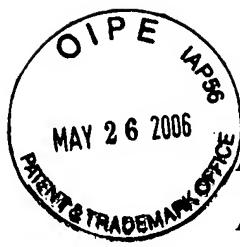


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**



**Appl. No.** : **10/611,896**  
**Applicants** : **Yu-Chou Lee, et al.**  
**Filed** : **July 3, 2003**  
**Title** : **THIN FILM TRANSISTOR STRUCTURE AND  
MANUFACTURING METHOD THEREOF**  
**TC/A.U.** : **2811**  
**Examiner** : **TRAN, THIEN F**

**AMENDMENT AFTER FINAL OFFICE ACTION**

Mail Stop RCE  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Final Office Action mailed on March 1, 2006. Applicants respectfully submit a Request for Continued Examination (RCE) under 37 CFR 1.114 and respectfully request that the Examiner reconsider the amended application according to the following remarks.

Please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.